

525, 034

(12) INTERNATIONAL APPLICATION PUBLISHED UNDER THE PATENT COOPERATION TREATY (PCT)

(19) World Intellectual Property
Organization
International Bureau

17 FEB 2005

(43) International Publication Date
11 March 2004 (11.03.2004)

PCT

(10) International Publication Number
WO 2004/021083 A1(51) International Patent Classification⁷: G03F 7/00,
9/00 // G11B 5/84[SE/SE]; Förridaregatan 13, S-216 21 Malmö (SE). AN-
DERSSON, Peter [SE/SE]; Sveavägen 135, S-113 50
Stockholm (SE).(21) International Application Number:
PCT/SE2003/001245(74) Agents: LINDBERG, Olle et al.; Albihns Malmö AB,
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(22) International Filing Date: 31 July 2003 (31.07.2003)

(25) Filing Language: English

(26) Publication Language: English

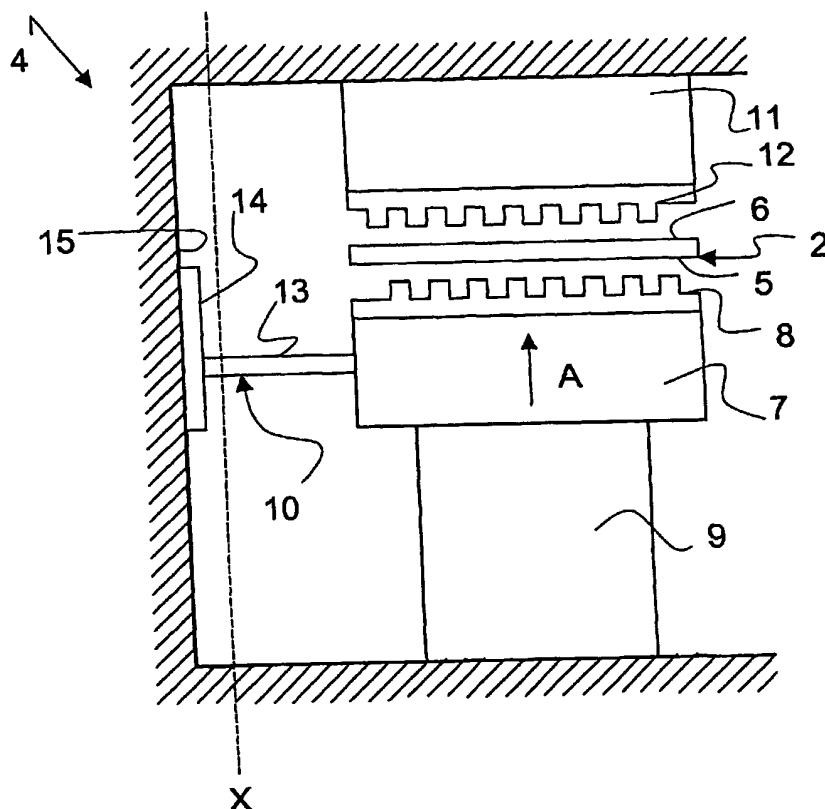
(30) Priority Data:
0202550-0 27 August 2002 (27.08.2002) SE
60/406,052 27 August 2002 (27.08.2002) US(81) Designated States (*national*): AE, AG, AL, AM, AT, AU,
AZ, BA, BB, BG, BR, BY, BZ, CA, CH, CN, CO, CR, CU,
CZ, DE, DK, DM, DZ, EC, EE, ES, FI, GB, GD, GE, GH,
GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KP, KR, KZ, LC,
LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW,
MX, MZ, NI, NO, NZ, OM, PG, PH, PL, PT, RO, RU, SC,
SD, SE, SG, SK, SL, SY, TJ, TM, TN, TR, TT, TZ, UA,
UG, US, UZ, VC, VN, YU, ZA, ZM, ZW.(71) Applicant (*for all designated States except US*): OBDU-
CAT AB [SE/SE]; P.O. Box 580, S-201 25 Malmö (SE).(84) Designated States (*regional*): ARIPO patent (GH, GM,
KE, LS, MW, MZ, SD, SL, SZ, TZ, UG, ZM, ZW),
Eurasian patent (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM),
European patent (AT, BE, BG, CH, CY, CZ, DE, DK, EE,
ES, FI, FR, GB, GR, HU, IE, IT, LU, MC, NL, PT, RO,

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[Continued on next page]

(54) Title: DEVICE FOR TRANSFERRING A PATTERN TO AN OBJECT



(57) Abstract: A device (4) for transferring a pattern to an object (2). The invention relates especially to production of micro and nanostructures. The device comprises an alignment means (10) arranged in connection with a first contacting means (7) for controlling the motion of the first stamp (8) in a direction perpendicular to the pressing direction (A), and a second contacting means (11) having a second stamp (12) adapted to imprint a second pattern in the second surface (6) of the object (2), and a pressing means (9) further adapted to press the second stamp (12) into contact with the second surface (6) of the object (2) in the pressing direction (A). Hereby is obtained a device of a simple design, which has a high accuracy of the alignment of the stamps in relation to the object.

WO 2004/021083 A1



SE, SI, SK, TR), OAPI patent (BF, BJ, CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR, NE, SN, TD, TG).

Published:

— with international search report

Declaration under Rule 4.17:

— of inventorship (Rule 4.17(iv)) for US only

For two-letter codes and other abbreviations, refer to the "Guidance Notes on Codes and Abbreviations" appearing at the beginning of each regular issue of the PCT Gazette.

DEVICE FOR TRANSFERRING A PATTERN TO AN OBJECTField of the Invention

The present invention relates generally to transferring a
5 pattern from a stamp to an object. The invention relates
especially to production of micro- and nanostructures.

Background Art

A promising technique of producing nanostructures, i.e.
10 structures in the order of 100nm and smaller, is so-
called nanoimprint lithography, however this technique
may also be used to microstructures. This technique is
described in the document US-A-5,772,905, which is incor-
porated herewith by reference. In such lithography, the
15 main steps of which are schematically shown in Figs 1a-d,
a pattern of nanostructures is transferred from a stamp 1
to an object 2. The object 2 consists of a substrate 2a
and, applied thereto, a film 2b of a polymer material
(resist). After heating of the film 2b to a suitable tem-
20 perature, the stamp 1 is pressed into the same (Fig. 1b).
The stamp 1 is then released from the object 2 when re-
cesses 3 of a desired depth have been formed in the layer
2b (Fig. 1c). Subsequently any remaining film in the re-
cesses 3 is removed, for instance by etching, thereby ex-
25 posing the substrate or in some other material which is
applied to the substrate.

A device according to the above mentioned US patent for
carrying out the above lithographic process comprises a
30 first contacting means with receiving surface for the
stamp, a second contacting means for contacting or join-

ing the first and second receiving surfaces with each other.

The film applied to the substrate is very thin, typically
5 50-200 nm. For even structuring of the object, the stamp
and the object must thus be mutually parallel with an accuracy of a few nanometres.

Especially due to the fact that the high requirements in
10 accuracy, when manufacturing micro and nanostructures, in
the alignment between the stamp and the object, there is
a great need for exact control of the movement of the
stamp in the direction perpendicular to the pressing
direction, as a small displacement of the stamp can have
15 the severe consequence that the pattern transferred to
the object cannot be used.

The substrate is usually made of a brittle material, e.g.
Si/SiO₂, GaAs or InP, and the pressure exerted upon the
20 substrate during contact is high, typically 4-10 MPa.

In the case where a pattern is to be transferred to both
surfaces of the object in a single process, there is established a need for a still more reliable controlling of
25 the stamp in the direction perpendicular to the pressing
direction. Particularly in this instance it is important
that the transferring of the patterns has a high accuracy
as the matter could be that the object is totally destroyed and thereby not usable.

30

Furthermore to obtain that the pattern is transferred to
the object in expedient manner, the object is heated to a
temperature approximately between 150 and 300 °C. This

high temperature of the object during pressing causes that heat is transferred from the object to the surroundings, i.e. the stamp as well as the contacting means. During this heat transmission an uneven temperature distribution (also during subsequent cooling of the object) in the known devices is obtained, whereby changes in the shapes and sizes of the contacting means as well as stamps occur and thereby displacements of the elements in the devices may arise. This will have a severe consequence for the final product, due to the fact that only a minimal displacement of the pattern in relation to the intended placement will render the product useless.

Summary of the Invention

15 An object of the present invention is to wholly or partly overcome the above disadvantages of the prior art. More specifically, it is an object to provide a device for transferring a pattern to an object, said device having a high accuracy of the stamps during the pressing.

20

It is also an object of the present invention to provide a device which is not influenced by the deviating temperatures of the object.

25 It is furthermore an object of the invention to provide a device which is simple in construction and which in expedient manner may be used to transfer patterns to both surfaces on the object at the same time.

30 It is a specific object of the invention to provide a device which is suited for transferring micro- or nanostructures to the object.

The above objects, together with numerous other objects, advantages and features which will become evident from the below description, are accomplished by a solution in accordance to the present invention by a device for

5 transferring a pattern to an object, said object having a first surface and a second surface, said device comprising a first contacting means having a first stamp adapted to imprint a first pattern in the first surface of the object, and a pressing means adapted to press the

10 first stamp into contact with the first surface of the object in a pressing direction. Furthermore, an alignment means is arranged in connection with the first contacting means for controlling the motion of the first stamp in a direction perpendicular to the pressing direction, and a

15 second contacting means having a second stamp is adapted to imprint a second pattern in the second surface of the object, and the pressing means is further adapted to press the second stamp into contact with the second surface of the object in the pressing direction.

20

Hereby is obtained a device of a simple design, which has a high accuracy of the alignment of the stamps in relation to the object, thus during operation of the device the displacement, which occurs in the prior art, is limited to an almost imperceptible level inside the limits

25 of accuracy, which is necessary when the pattern is transferred at the same time to both the first surface and the second surface of the object.

30 During operation of the device according to the present invention the pressing means is pressing the first stamp into contact with the first surface of the object in a pressing direction. Throughout this movement the align-

ment means is controlling the motion of the first stamp in a direction perpendicular to the pressing direction, thus securing that the first stamp will come into contact with the first surface of the object exactly as intended.

5 As the pressing means is further pressing in the pressing direction, the second stamp will come into contact with the second surface of the object, whereby the first stamp will imprint the first pattern in the first surface of the object and at the same time the second stamp will im-
10 print the second pattern in the second surface of the object. The device is of a simple design and can thereby be formed to allow contacting of the stamps with the object under high pressure.

15 According to a preferred embodiment according to the present invention alignment means may be arranged in connection with the second contacting means. A higher accuracy is hereby secured, thus, it is obtained that no mutual displacement between the contacting means during the
20 pressing occurs.

In an expedient embodiment according to the invention the alignment means may be an arm, which protrude from at least the first contacting means to a rail adapted to a
25 stationery support and wherein the arm is arranged to slide in the pressing direction on the rail. Hereby is obtained a simple construction of the device with a high alignment accuracy. Furthermore the alignment means may be incorporated in existing devices without construction-
30 wise alterations.

Advantageously according to the invention the size of the contacting means may be substantially identical. Hereby

is obtained that the heat transfer capability for the two contacting means is essentially the same, whereby the heat transferred to them does not influence their mutual alignment. The matter is that the thermal displacement
5 which may occur is substantially the same for both contacting means.

Further according to the invention heating means be may arranged for heating the object to a predetermined
10 temperature. The temperature of the object may be heated to 500 °C, preferably between 250 and 350 °C, most preferably between 280 and 320 °C. The above mentioned temperature intervals depend upon the material of the substrate which will be appreciated by the skilled person.

15

According to the invention a temperature sensor may be adapted to monitor the temperature of the object during the stamping.

20 A pressure sensor may be arranged according to the invention in connection with the pressing means. Furthermore, a control unit may be adapted, based on the pressure detected by the pressure sensor, to cause the pressing means to establish a given pressure between the stamps
25 and the object.

The stamp may in a preferred expedient embodiment according to the present invention have a pattern of micro- or nanostructures.

30

The object may preferably comprise a substrate and a layer of a polymer material applied thereto.

In a preferred embodiment according to the invention the pressing means may be arranged as mechanically operating means, such as a jack or a screw. Hereby is obtained that the inaccuracy in alignment, which often arises in hydraulic presses, is minimised.

In an expedient embodiment according to the invention a heat transmission barrier may be arranged between the contacting means and the pressing means to minimize the heat transfer here between. Hereby is obtained that no uneven heat transfer throughout the device occurs and thereby inaccuracy in the alignment as a consequence.

Brief Description of the Drawings

The invention and its advantages will be described in more detail below with reference to the accompanying schematic drawings, which by way of example illustrate currently preferred embodiments of the invention.

Figures 1a-1d illustrate transfer of a pattern from a stamp to a substrate by nanoimprint lithography according to a known process,

Fig. 2 is a schematic view of a device according to a first embodiment of the invention.

Fig. 3 is a schematic view of a device according to a second embodiment of the invention.

Fig. 4 is a schematic view of a part of a device according to a third embodiment of the invention.

Fig. 5 is a schematic view of a part of a device according to a fourth embodiment of the invention.

All the figures are highly schematic and not necessarily to scale, and they show only parts which are necessary in order to elucidate the invention, other parts being omitted or merely suggested.

Description of Preferred Embodiments

10 Fig. 2 is a schematic view of a device according to a first embodiment of the invention. The device 4 for transferring a pattern to the object 2, said object 2 having a first surface 5 and a second surface 6, said device 4 comprising a first contacting means 7 having a
15 first stamp 8 adapted to imprint a first pattern in the first surface 5 of the object 2.

A pressing means 9 is furthermore adapted to press the first stamp 8 into contact with the first surface 5 of
20 the object 2 in a pressing direction, indicated by arrow A. The pressing direction is in this embodiment shown as a vertical movement of the pressing means 9, however, it may also according to the invention be horizontal or inclined movements, which will be appreciated by the
25 skilled person. The pressing means 9 can be of a prior-art type, such as a hydraulically or pneumatic operated press. However, according to the invention the the pressing means may be arranged as mechanically operating means, such as a jack or a screw, whereby a simple
30 and inexpensive device is obtained, still having a high precision in pressing.

Common for the pressing means are that they shall be able to apply an exact predetermined pressure to be used in the transferring of the patterns to the object. The pressure exerted is typically 4-10 MPa.

5

The pressing means 9 is in this embodiment shown in connection with the first contacting means 7 only, but may according to the invention also be arranged in connection with the second contacting means 11 as well as in connection with both contacting means.

10

An alignment means 10 is arranged in connection with the first contacting means 7 for controlling the motion of the first stamp 8 in a direction perpendicular to the pressing direction A. Furthermore there is a second contacting means 11 having a second stamp 12 adapted to imprint a second pattern in the second surface 6 of the object 2, and the pressing means 9 further adapted to press the second stamp 12 into contact with the second surface 6 of the object 2 in the pressing direction A.

15

20

In this embodiment the alignment means 10 comprises an arm 13, which protrude from at least the first contacting means 7 to a rail 14 adapted to a stationery support 15 and wherein the arm 13 is arranged to slide in the pressing direction A on the rail 14.

25

Furthermore it is expedient according to the invention that the arm is provided with a pretension whereby it is obtained that there is no displacement between the rails and the contacting means. Preferably the arm and rails may be made of metal, such as for instance stainless steel.

30

Fig. 3 is a schematic view of a device 4 according to a second embodiment of the invention. In this device 4 alignment means 10 is also arranged in connection with the second contacting means 11. In this embodiment the size of the contacting means 7 and 11 is furthermore substantially identical.

The device may also according to the invention comprise heating means (not shown) arranged for heating the object to a predetermined temperature. The temperature of the object may be heated to 500 °C, preferably between 250 and 350 °C, most preferably between 280 and 320 °C.

Further a temperature sensor (not shown) may be adapted to monitor the temperature of the object 2 during the pressing.

Especially with these high temperatures applied to the object 2, it is required to control in an exact manner the heat transfer from the object 2 to the surroundings, i.e. the stamps 8 and 12 as well as the contacting means 7 and 11. If the heat transfer is not controlled this could have severe consequences as an uneven temperature stabilisation throughout the device will influence the alignment between the object 2 and the stamps 8 and 12.

Particularly in the embodiment illustrated in Fig. 3 an exact heat transfer is obtained as the contacting means 7 and 11 are substantially identical in size as well as both contacting means 7 and 11 have aligning means 10 arranged in connection with them also having substantially

identical sizes.

Furthermore a heat transmission barrier 16 may be arranged between the contacting means 7 and the pressing means 9 to minimize the heat transfer here between. A heat transmission barrier 17 may also be arranged between the contacting means 11 and the stationery support 15.

By the inventive idea the thermal movements of the contacting means are perpendicular to the pressing direction equal with a common line X as shown in Fig. 2.

The device 4 may furthermore comprise cooling means (not shown) for cooling the object during the pressing. Also in this instance it is required to control the heat transfer in an exact manner for obtaining a temperature stabilisation of the contacting means 7 and 11 as well as to prevent changes in their shapes.

In Fig. 4 and Fig. 5 further embodiments according to the invention are shown, wherein the pressing means is partly or fully replaced by the gas imprint technique.

In Fig. 4 there is, in connection with the second contacting means 11, arranged a sealing gasket 18, which essentially extends around the area of the pattern of the second stamp 12. The sealing gasket 18 may be housed in a groove (not shown) in the second contacting means 11 and be attached thereto in any suitable fashion. The sealing gasket may also be arranged in a corresponding groove in the stamp 12. The surface of the contacting means 11, the sealing gasket 18 and the back surface 19 of the stamp 12 together define a cavity 20, which will function as a

pressure cavity for providing a pressure on the back surface of the stamp 12.

5 The pressure in the pressure cavity 20 is controlled via a pressure medium channel 21, which in turn is connected to an appropriate pressure control apparatus (not shown). The pressure medium channel 21 may be provided with a valve (not shown) for controlling the flow in the pressure medium channel. The valve may be adapted for limiting the flow in the pressure medium channel, so as to prevent major outflows of pressure medium in case e.g. the stamp 12 or the object 2 should break.

15 It is also possible to provide the pressure cavity 20 and/or the pressure medium channel 21 with a pressure sensor (not shown). Such a pressure sensor may provide an accurate measurement of the pressure inside the cavity. The measurement may be used to control the pressure in order to prevent damage to the object and/or the stamp. 20 It is also possible to monitor the pressure in the cavity 20 with a view to cutting off the flow of pressure medium in the pressure medium channel 21 in case of a rapid decline in pressure, such as would be the case when a stamp or an object breaks.

25 In order to generate a sufficient contact pressure between the sealing gasket, the stamp and the contacting means, a pressure may be added on the contacting means after the stamp and the object have been aligned.

30

The device is arranged to press the first and second contacting means towards each other and to provide a static gas pressure within said pressure cavity. In the embodiment shown in Fig. 4 the first contacting means is 35 operated by pressing means 9, such as for instance hydraulic or mechanical presses. The static gas pressure

may be arranged to assume at least two states. In a first state, the static gas pressure within said pressure cavity is essentially equal to or lower than a gas pressure of a surrounding environment. In a second state, the static gas pressure within the pressure cavity is substantially higher than in the first state. In the first state, an average distance between a back surface of the stamp 19 and the surface area of the second contacting means 11 may be between 0.01 and 4 millimeters, preferably between 0.3 and 1 millimeters and more preferably between 0.4 and 0.6 millimeters.

By providing a static pressure according to the invention, the pressure on the stamp or object back surface will be uniform, thus ensuring that the stamp and the object are parallel and that there are no local pressure maximums, whereby an expedient imprint of a pattern is obtained.

Using a gas instead of e.g. hydraulic oil, preferably an inert gas, furthermore reduces the risk of contaminating the environment surrounding the device.

In Fig. 5 a part of the device is shown wherein both the first contacting means as well as the second contacting means are operated by the gas imprint technique as explained above in relation to Fig. 4.

According to the invention a pressure sensor (not shown) may in expedient manner be arranged in connection with the pressing means 9. Furthermore a control unit (not shown) may be adapted, based on the pressure detected by the pressure sensor, to cause the pressing means to establish a given pressure between the stamps and the object.

The object 2 may be single- or double-sided circuit boards or single- or double-sided CD-ROMs or DVDs. The object may in expedient manner have a shape corresponding to its subsequent application, for instance round or
5 quadrangular or other geometric shapes as will be appreciated by a skilled person.

Although the invention above has been described in connection with preferred embodiments of the invention, it
10 will be evident for a person skilled in the art that several modifications are conceivable without departing from the invention as defined by the following claims.

CLAIMS

1. A device (4) for transferring a pattern to an object (2), said object (2) having a first surface (5) and a second surface (6), said device (4) comprising a first contacting means (7) having a first stamp (8) adapted to imprint a first pattern in the first surface (5) of the object (2), and a pressing means (9) adapted to press the first stamp (12) into contact with the first surface (5) of the object (2) in a pressing direction (A), characterised in that said device (4) further comprises an alignment means (10) arranged in connection with the first contacting means (7) for controlling the motion of the first stamp (8) in a direction perpendicular to the pressing direction (A), and a second contacting means (11) having a second stamp (12) adapted to imprint a second pattern in the second surface (6) of the object (2), and the pressing means (9) further adapted to press the second stamp (12) into contact with the second surface (6) of the object (2) in the pressing direction (A).
2. A device (4) according to claim 1, wherein an alignment means (10) is arranged in connection with the second contacting means (11).
3. A device (4) according to claims 1 or 2, wherein the alignment means (10) is an arm (13), which protrude from at least the first contacting means (7) to a rail (14) adapted to a stationery support (15) and wherein the arm (13) is arranged to slide in the pressing direction (A) on the rail (14).
4. A device (4) according to claim 1, wherein the size of

the contacting means (7, 11) is substantially identical.

5 5. A device (4) according to claim 1, wherein a heating means is arranged for heating the object (2) to a predetermined temperature.

10 6. A device (4) according to claim 5, wherein the temperature of the object (2) is heated to 500 °C, preferably between 250 and 350 °C, most preferably between 280 and 320 °C.

15 7. A device (4) according to claims 5 or 6, wherein a temperature sensor is adapted to monitor the temperature of the object (2) during the pressing.

8. A device (4) according to claim 1, wherein a pressure sensor is arranged in connection with the pressing means (9).

20 9. A device (4) according to claim 8, wherein a control unit is adapted, based on the pressure detected by the pressure sensor, to cause the pressing means (9) to establish a given pressure between the stamps (8, 12) and the object (2).

25 10. A device (4) according to claim 1, wherein the stamp (8, 12) has a pattern of micro- or nanostructures.

30 11. A device (4) according to claim 1, wherein the object (2) comprises a substrate and a layer of a polymer material applied thereto.

12. A device (4) according to claim 1, wherein the press-

ing means (9) is arranged as mechanically operating means, such as a jack or a screw.

13. A device (4) according to claim 1, wherein the contacting means (7, 11) are made of metal, preferably stainless steel.

14. A device (4) according to claim 1, wherein a heat transmission barrier (16) is arranged between the contacting means (7) and the pressing means (9) to minimize the heat transfer here between.

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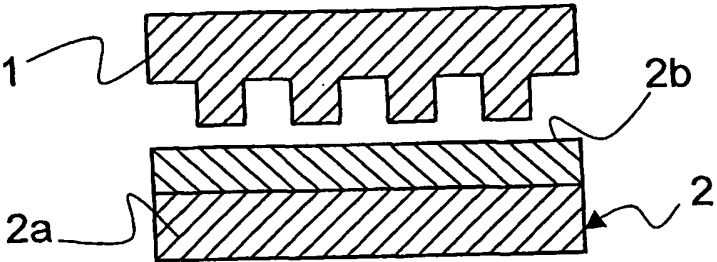


Fig. 1a

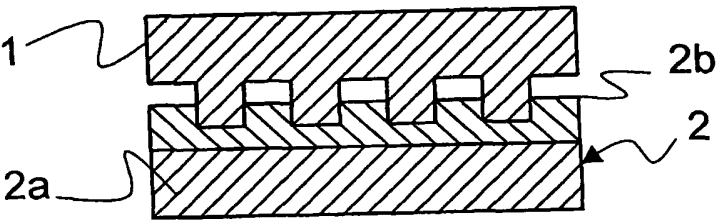


Fig. 1b

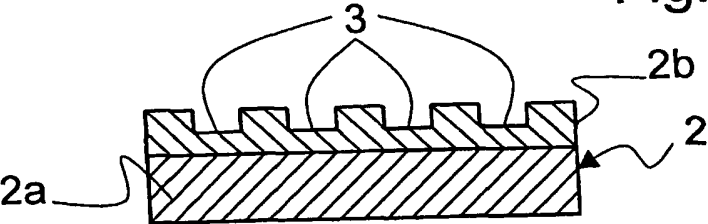


Fig. 1c

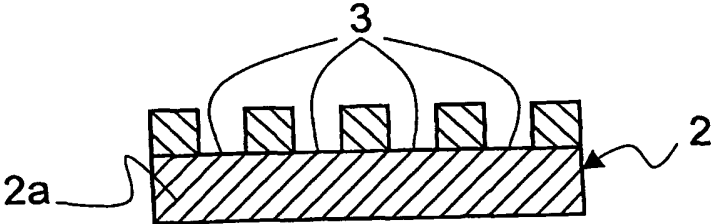


Fig. 1d

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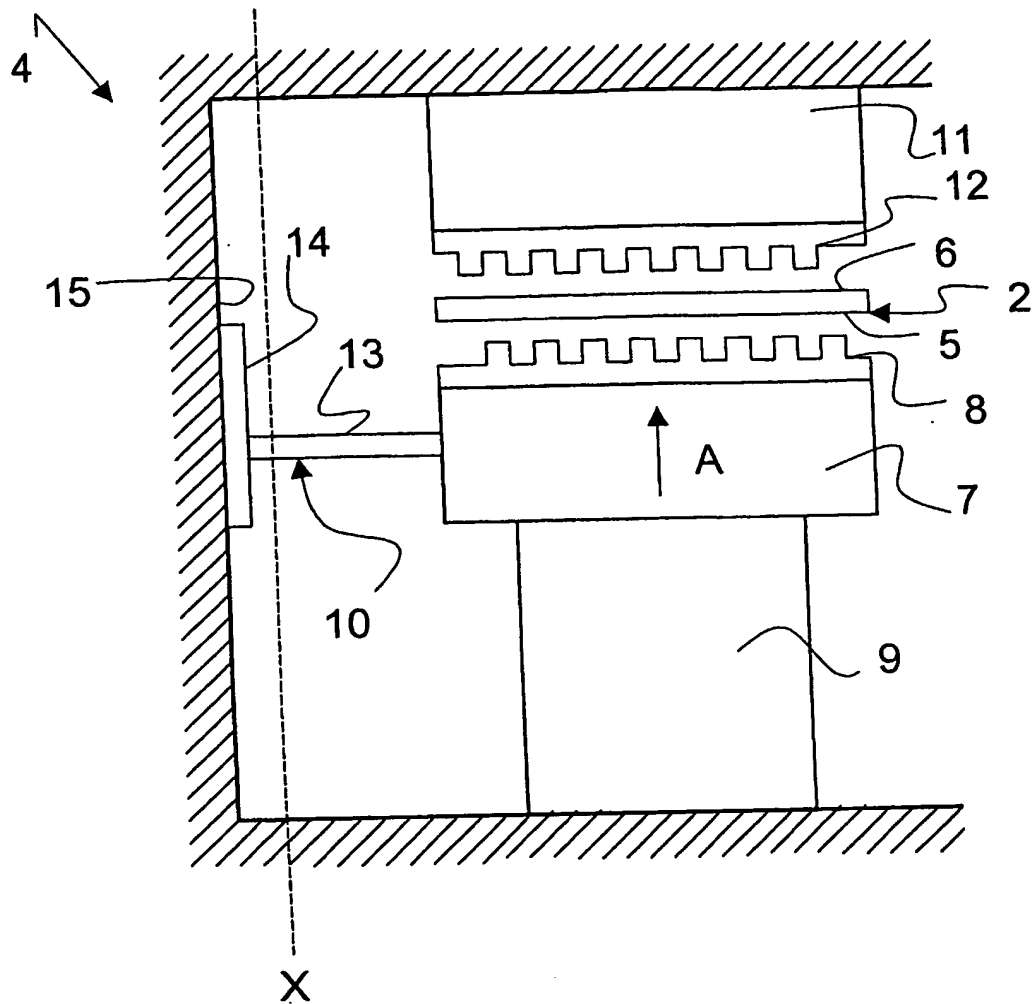


Fig. 2

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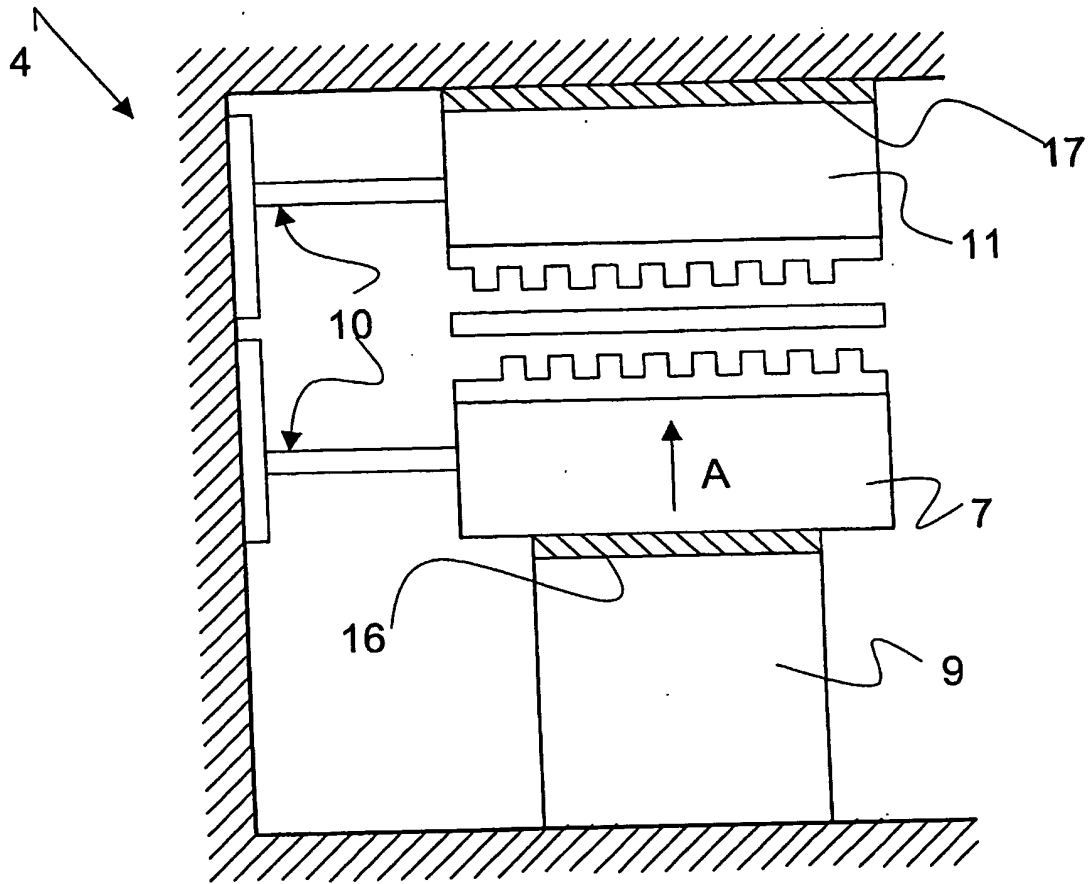
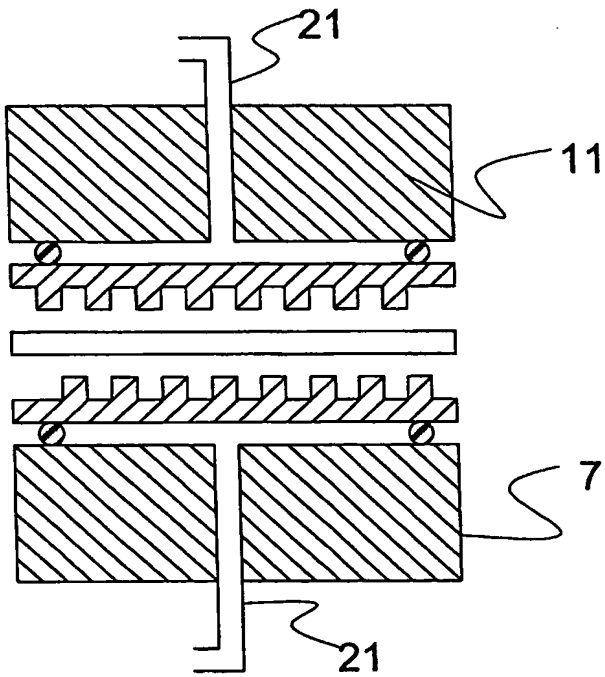
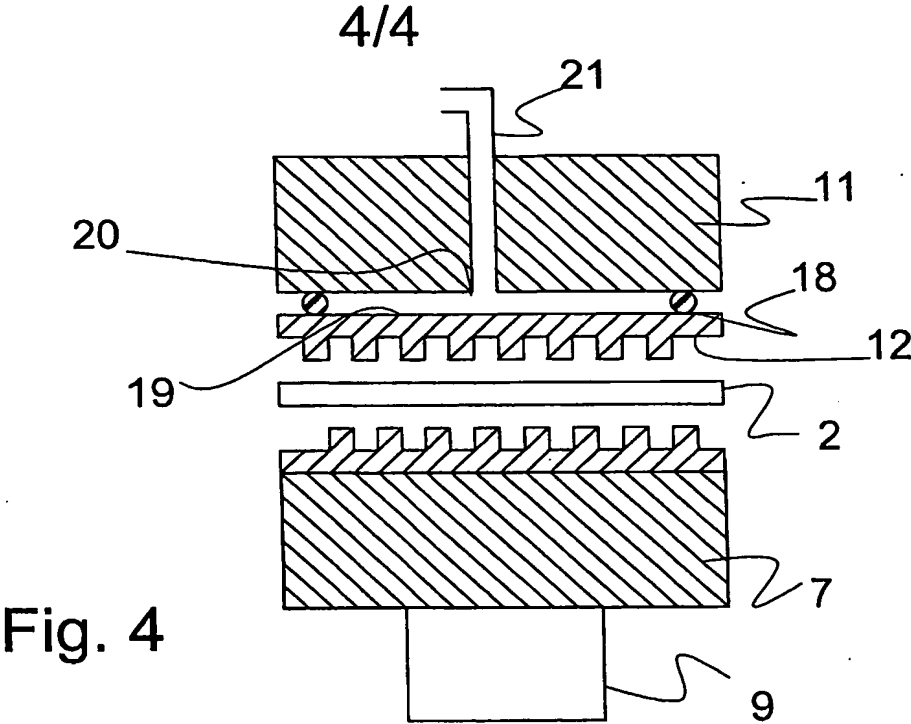


Fig. 3



INTERNATIONAL SEARCH REPORT

International application No.

PCT/SE 03/01245

A. CLASSIFICATION OF SUBJECT MATTER

IPC7: G03F 7/00, G03F 9/00 // G11B 5/84

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)

IPC7: G03F, G11B

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

SE,DK,FI,NO classes as above

Electronic data base consulted during the international search (name of data base and, where practicable, search terms used)

EPO-INTERNAL, WPI DATA, PAJ, INSPEC, COMPENDEX, TDB

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category*	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
A	US 2002/0098426 A1 (S.V. SREENIVASAN ET AL), 25 July 2002 (25.07.02), page 4 - page 5; page 16, figures 1,2,38 --	1-14
A	US 5772905 A (STEPHEN Y. CHOU), 30 June 1998 (30.06.98), column 4, line 7 - column 5, line 64; column 9, line 31 - column 6, line 67, figures 1,9 -- -----	1-14



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International application No.
PCT/SE 03/01245

Patent document cited in search report	Publication date	Patent family member(s)	Publication date
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US 5772905 A	30/06/98	US 6309580 B	30/10/01
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